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APPLICANTS Yoshinobu Sekiguchi, Tokyo, JAPAN; Takao Yonehara, Tokyo, JAPAN; Makoto Koto, Tokyo, JAPAN; Masahiro Okuda, Tokyo, JAPAN; Tetsuya Shimada, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP05/11388 06/15/2005				
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Verified and Acknowledged	/CALVIN LEE/ Examiner's Signature		JAPAN	6
			TOTAL CLAIMS	INDEPENDENT CLAIMS
			31	2
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TITLE Semiconductor film manufacturing method and substrate manufacturing method				
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